

# TRANSMITTAL OF FORMAL DRAWINGS

Docket No.

SEC.584

In Re Application Of: **Ki-Sang KIM et al.**



Serial No.	Filing Date	Confirmation No.	Examiner	Art Unit
09/237,229	01/26/1999	9480	Lund, Jeffrie R.	1763

Invention: **MULTI-CHAMBER SYSTEM HAVING COMPACT INSTALLATION SET-UP FOR AN ETCHING FACILITY FOR SEMICONDUCTOR DEVICE MANUFACTURING**

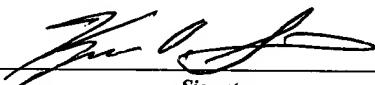
Address to:

**Assistant Commissioner for Patents  
Washington, D.C. 20231**

Transmitted herewith are:

7 sheets of formal drawing(s) for this application.

- Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).



*Signature*

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Dated: **19 November 2002**

I certify that this document and attached formal drawings are being deposited on **19 November 2002** with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

*Signature of Person Mailing Correspondence*

*Typed or Printed Name of Person Mailing Correspondence*